



520.35237VX3

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: T. KAJI, et al.  
Application No.: 10/052,538  
Filed: January 23, 2002  
For: PLASMA PROCESSING APPARATUS PROCESSING METHOD  
Art Unit: 1763  
Examiner: A. M. Crowell

*Entered with DC 9/30/05  
MW 10/14/05*

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

September 20, 2005

Sir:

In response to the Office Action dated May 20, 2005, the period of response for which extension is requested by the attached Petition for Extension of Time, please amend the above-identified application as listed below and set forth on the following pages:

**Amendments to the Claims and**

**Remarks are included following the amendments.**

09/22/2005 HRLI11 00000059 10052538

01 FC:1202  
02 FC:1201

550.00 OP  
200.00 OP